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CONFIRMATION NO. 1790

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**\*\* CONTINUING DATA \*\*\*\*\***  
 This application is a 371 of PCT/JP04/10301 07/20/2004

**\*\* FOREIGN APPLICATIONS \*\*\*\*\***  
 JAPAN 2003-276482 07/18/2003

**\*\* IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\***  
 02/01/2007

Foreign Priority claimed 35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 13	<b>TOTAL CLAIMS</b> 31	<b>INDEPENDENT CLAIMS</b> 2
Verified and Acknowledged	/FELISA CARLA HITESHEW/ Examiner's signature	Initials				

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**TITLE**  
 Method for fixing metal particles and method for manufacturing substrate containing metal particles, method for manufacturing substrate containing carbon nanotube, and method for manufacturing substrate containing semiconductor-crystalline rod, employing thereof

<b>FILING FEE RECEIVED</b> 2660	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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